

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	341	(crystalline crystallize crystallized crystallizing crystal) with (alumina (aluminum adj oxide) "al.sub.2 o.sub.3") with (dielectric)	US-PGPUB; USPAT	OR	ON	2005/01/21 14:52
L2	12	1 and ((upper top) near2 (electrode plate)) with ((ruthenium ru titanium ti metal) and (silicon polysilicon))	US-PGPUB; USPAT	OR	ON	2005/01/21 14:53
L3	10	2 not (@ad>"20021230" or @rlad>"20021030")	US-PGPUB; USPAT	OR	ON	2005/01/21 15:57
L4	2650	((((bottom lower) near2 (electrode plate)) with ((undoped adj (poly polysilicon)) (doped amorphous))) not (@ad>"20021230" or @rlad>"20021030"))	US-PGPUB; USPAT	OR	ON	2005/01/21 16:55
L5	30	((((bottom lower) near2 (electrode plate)) with ((undoped adj (poly polysilicon)) (doped amorphous)) with advantag\$) not (@ad>"20021230" or @rlad>"20021030"))	US-PGPUB; USPAT	OR	ON	2005/01/21 16:55
L6	0	((((bottom lower) near2 (electrode plate)) with ((undoped adj (poly polysilicon)) (doped adj amorphous)) with advantag\$) not (@ad>"20021230" or @rlad>"20021030"))	US-PGPUB; USPAT	OR	ON	2005/01/21 16:55
L7	98	((((bottom lower) near2 (electrode plate)) with ((undoped adj (poly polysilicon)) (doped adj amorphous))) not (@ad>"20021230" or @rlad>"20021030"))	US-PGPUB; USPAT	OR	ON	2005/01/21 16:58
L8	3	((((bottom lower) near2 (electrode plate)) with ((undoped adj (poly polysilicon)) and (doped adj amorphous))) not (@ad>"20021230" or @rlad>"20021030"))	US-PGPUB; USPAT	OR	ON	2005/01/21 16:58
S1	643	((silicon adj (oxide dioxide)) "SiO" "Sio.sub.2" "SiO.sub.x") with (ALD (atomic adj layer) ale mbe))	US-PGPUB; USPAT	OR	ON	2004/03/16 19:06
S2	156	(((((silicon adj (oxide dioxide)) "SiO" "Sio.sub.2" "SiO.sub.x") with (ALD (atomic adj layer) ale mbe))) and (aluminum adj oxide "al.sub.2 o.sub.3" "al.sub.x o.sub.y"))	US-PGPUB; USPAT	OR	OFF	2004/03/16 18:55

S3	130	((((silicon adj (oxide dioxide)) "SiO" "Sio.sub.2" "SiO.sub.x") with (ALD (atomic adj layer) ale mbe))) and (aluminum adj oxide "al.sub.2 o.sub.3" "al.sub.x o.sub.y")) and (electrode or capacitor or plate)	US-PGPUB; USPAT	OR	ON	2004/03/19 10:54
S4	13	((((silicon adj (oxide dioxide)) "SiO" "Sio.sub.2" "SiO.sub.x") with (ALD (atomic adj layer) ale mbe))) and ((aluminum adj oxide "al.sub.2 o.sub.3" "al.sub.x o.sub.y") same (crystallizing crystallize crystalline crystallized))	US-PGPUB; USPAT	OR	ON	2004/03/18 20:48
S5	13	((((silicon adj (oxide dioxide)) "SiO" "Sio.sub.2" "SiO.sub.x") with (ALD (atomic adj layer) ale mbe))) and ((aluminum adj oxide "al.sub.2 o.sub.3" "al.sub.x o.sub.y") same (crystallizing crystallize crystalline crystallized))) not (@ad>"20030717" or @rlad>"20030717")	US-PGPUB; USPAT	OR	ON	2004/03/16 19:03
S6	129	((((silicon adj (oxide dioxide)) "SiO" "Sio.sub.2" "SiO.sub.x") with (ALD (atomic adj layer) ale mbe))) and (aluminum adj oxide "al.sub.2 o.sub.3" "al.sub.x o.sub.y")) and (electrode or capacitor or plate) not (@ad>"20030717" or @rlad>"20030717")	US-PGPUB; USPAT	OR	ON	2004/03/16 19:03
S7	9	(((silicon adj (oxide dioxide)) "SiO" "Sio.sub.2" "SiO.sub.x") with (ALD (atomic adj layer) ale mbe)) same (aluminum adj oxide "al.sub.2 o.sub.3" "al.sub.x o.sub.y") same (capacitor electrode plate)	US-PGPUB; USPAT	OR	ON	2004/03/16 19:10
S8	183	(((silicon adj (oxide dioxide)) "SiO" "Sio.sub.2" "SiO.sub.x")) same (aluminum adj oxide "al.sub.2 o.sub.3" "al.sub.x o.sub.y") same ((capacitor electrode plate) adj (dielectric insulating insulator))	US-PGPUB; USPAT	OR	ON	2004/03/16 19:11
S9	29	(((silicon adj (oxide dioxide)) "SiO" "Sio.sub.2" "SiO.sub.x")) with (aluminum adj oxide "al.sub.2 o.sub.3" "al.sub.x o.sub.y") with ((capacitor electrode plate) adj (dielectric insulating insulator))	US-PGPUB; USPAT	OR	ON	2004/03/18 21:36
S10	160	((((silicon adj (oxide dioxide)) "SiO" "Sio.sub.2" "SiO.sub.x") with (ALD (atomic adj layer) ale mbe))) and (aluminum adj oxide "al.sub.2 o.sub.3" "al.sub.x o.sub.y")	US-PGPUB; USPAT	OR	ON	2004/03/18 21:58

S11	1	("6660660").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/03/18 20:48
S12	1	((("6660660").PN.) and (capacitor plate electrode)	US-PGPUB; USPAT	OR	OFF	2004/03/18 20:48
S13	1	((("6660660").PN.) and (capacitor plate electrode)	US-PGPUB; USPAT	OR	ON	2004/03/18 20:48
S14	1	09/791072	US-PGPUB; USPAT	OR	ON	2004/03/18 21:36
S15	1	09/791072 and (ALD with (silicon adj (oxide dioxide)))	US-PGPUB; USPAT	OR	ON	2004/03/18 21:37
S16	0	09/791072 and (ALD with "sio. sub.2")	US-PGPUB; USPAT	OR	ON	2004/03/18 21:43
S17	1	09/791072 and (silane)	US-PGPUB; USPAT	OR	ON	2004/03/18 21:52
S18	1	("6500707").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/03/18 21:52
S19	0	("64and((cylindricalcylindercupstacked)adjcapacitor)").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/03/18 21:53
S20	0	((("6500707").PN.) and ((cylindrical cylinder cup stacked) adj capacitor)	US-PGPUB; USPAT	OR	OFF	2004/03/18 21:53
S21	17794	(crystalline crystallize crystallized crystallizing crystal) with (alumina (aluminum adj oxide) "al.sub.2 o. sub.3")	US-PGPUB; USPAT	OR	ON	2004/03/18 22:00
S22	1	(crystalline crystallize crystallized crystallizing crystal) with (alumina (aluminum adj oxide) "al.sub.2 o. sub.3") with (capacitor adj dielectric)	US-PGPUB; USPAT	OR	ON	2004/03/18 22:00
S23	289	(crystalline crystallize crystallized crystallizing crystal) with (alumina (aluminum adj oxide) "al.sub.2 o. sub.3") with (dielectric)	US-PGPUB; USPAT	OR	ON	2005/01/21 14:51
S24	109	((crystalline crystallize crystallized crystallizing crystal) with (alumina (aluminum adj oxide) "al.sub.2 o. sub.3") with (dielectric)) and (DRAM capacitor)	US-PGPUB; USPAT	OR	ON	2004/03/18 22:03
S25	77	(crystalline crystallize crystallized crystallizing crystal) near2 (alumina (aluminum adj oxide) "al. sub.2 o.sub.3") with (dielectric)	US-PGPUB; USPAT	OR	ON	2004/03/18 22:03

S26	25	((crystalline crystallize crystallized crystallizing crystal) near2 (alumina (aluminum adj oxide) "al.sub.2 o.sub.3") with (dielectric)) and (DRAM capacitor)	US-PGPUB; USPAT	OR	ON	2004/03/18 22:04
S27	12238	Park.in.	US-PGPUB; USPAT	OR	ON	2004/03/19 10:14
S28	4	Park.in. and (@AD="20020221")	US-PGPUB; USPAT	OR	ON	2004/03/19 10:16
S29	25	Park.in. and (@pD="20020221")	US-PGPUB; USPAT	OR	ON	2004/03/19 10:18
S30	8	(((((silicon adj (oxide dioxide)) "SiO" "Sio.sub.2" "SiO.sub.x") with (ALD (atomic adj layer) ale mbe))) with (aluminum adj oxide "al.sub.2 o.sub.3" "al.sub.x o.sub.y")) same(dielectric)	US-PGPUB; USPAT	OR	ON	2004/03/19 10:55
S31	105	(((((silicon adj (oxide dioxide)) "SiO" "Sio.sub.2" "SiO.sub.x") with (ALD (atomic adj layer) ale mbe))) and (aluminum adj oxide "al.sub.2 o.sub.3" "al.sub.x o.sub.y")) and (DRAM or capacitor or plate)	US-PGPUB; USPAT	OR	ON	2004/03/19 11:12
S32	1	10/227475	US-PGPUB; USPAT	OR	ON	2004/03/19 11:12
S33	1	10/227475 and (capacitor DRAM)	US-PGPUB; USPAT	OR	ON	2004/03/19 11:20
S34	1	10/227475 and (plasma)	US-PGPUB; USPAT	OR	ON	2004/03/19 13:55
S35	1	((silicon adj (oxide dioxide)) "Sio.sub.2") with (ald (atomic adj layer)) with pyridine	US-PGPUB; USPAT	OR	ON	2004/03/19 15:23
S36	3	((silicon adj (oxide dioxide)) "Sio.sub.2") same (ald (atomic adj layer)) same pyridine	US-PGPUB; USPAT	OR	ON	2004/03/19 14:03
S37	3	((silicon adj (oxide dioxide)) "Sio.sub.2") same (ald (atomic adj layer)) same (pyridine or "C.sub.2 H.sub.5 N")	US-PGPUB; USPAT	OR	ON	2004/03/19 14:09
S38	12	((silicon adj (oxide dioxide)) "Sio.sub.2") same (ald (atomic adj layer)) and (pyridine or "C.sub.2 H.sub.5 N")	US-PGPUB; USPAT	OR	ON	2004/03/19 14:37
S39	1	09/896955	US-PGPUB; USPAT	OR	ON	2004/03/19 14:37
S40	1	09/896955 and (atomic adj layer)	US-PGPUB; USPAT	OR	ON	2004/03/19 14:40
S41	1	10/227475	US-PGPUB; USPAT	OR	ON	2004/03/19 14:40

S42	1	10/227475 and seconds	US-PGPUB; USPAT	OR	ON	2004/03/19 14:42
S43	3	08/942522	US-PGPUB; USPAT	OR	ON	2004/03/19 14:43
S44	3	08/942522 and seconds	US-PGPUB; USPAT	OR	ON	2004/03/19 15:22
S45	1	(((silicon adj (oxide dioxide)) "Sio. sub.2") with (ald (atomic adj layer)) with ("siCl.sub.4" or DCS or HCD)) same seconds	US-PGPUB; USPAT	OR	ON	2004/03/19 15:25
S46	15	(((silicon adj (oxide dioxide)) "Sio. sub.2") with (ald (atomic adj layer)) with ("siCl.sub.4" or DCS or HCD)) and (pulse seconds)	US-PGPUB; USPAT	OR	ON	2004/03/19 15:37
S47	7	(((silicon adj (oxide dioxide)) "Sio. sub.2") with (ald (atomic adj layer)) with ("siCl.sub.4" or DCS or HCD)) and (pulse with seconds)	US-PGPUB; USPAT	OR	ON	2004/03/19 15:37
S48	46	(((silicon adj (oxide dioxide)) "Sio. sub.2") with ("siCl.sub.4" or DCS or HCD)) and (pulse with seconds)	US-PGPUB; USPAT	OR	ON	2004/03/19 15:41
S49	11	(((silicon adj (oxide dioxide)) "Sio.sub.2") with ("siCl.sub.4" or DCS or HCD)) and (pulse with seconds)) and ALD	US-PGPUB; USPAT	OR	ON	2004/03/19 15:42
S50	46	(((silicon adj (oxide dioxide)) "Sio. sub.2") with ("siCl.sub.4" or DCS or HCD or "si.sub.2 cl.sub.6" or "siH.sub.2 Cl.sub.2")) and (pulse with seconds)	US-PGPUB; USPAT	OR	ON	2004/03/19 15:57
S51	13	(((silicon adj (oxide dioxide)) "Sio.sub.2") with ("siCl.sub.4" or DCS or HCD or "si.sub.2 cl.sub.6" or "siH.sub.2 Cl.sub.2")) and (pulse with seconds)) and ((atomic adj layer) or ALD)	US-PGPUB; USPAT	OR	ON	2004/03/19 15:58
S52	113	(((silicon adj (oxide dioxide)) "Sio. sub.2") same ("siCl.sub.4" or DCS or HCD or "si.sub.2 cl.sub.6" or "siH.sub.2 Cl.sub.2")) and (pulse with seconds)	US-PGPUB; USPAT	OR	ON	2004/03/19 16:00
S53	17	(((silicon adj (oxide dioxide)) "Sio.sub.2") same ("siCl.sub.4" or DCS or HCD or "si.sub.2 cl.sub.6" or "siH.sub.2 Cl.sub.2")) and (pulse with seconds)) and ((atomic adj layer) or ALD)	US-PGPUB; USPAT	OR	ON	2004/03/19 16:37

S54	4	((((silicon adj (oxide dioxide)) "Sio.sub.2") same ("siCl.sub.4" or DCS or HCD or "si.sub.2 cl.sub.6" or "siH.sub.2 Cl.sub.2")) and (pulse with seconds)) and ((atomic adj layer) or ALD)) not (((silicon adj (oxide dioxide)) "Sio.sub.2") with ("siCl.sub.4" or DCS or HCD or "si.sub.2 cl.sub.6" or "siH.sub.2 Cl.sub.2")) and (pulse with seconds)) and ((atomic adj layer) or ALD))	US-PGPUB; USPAT	OR	ON	2004/03/19 15:58
S55	86	(((silicon adj (oxide dioxide)) "Sio.sub.2") same ("siCl.sub.4" or DCS or HCD or "si.sub.2 cl.sub.6" or "siH.sub.2 Cl.sub.2")) and ((atomic adj layer) ald)	US-PGPUB; USPAT	OR	ON	2004/03/19 16:39
S56	22	((((silicon adj (oxide dioxide)) "Sio.sub.2") same ("siCl.sub.4" or DCS or HCD or "si.sub.2 cl.sub.6" or "siH.sub.2 Cl.sub.2")) and (pulse with (ms secs sec msec seconds))) and ((atomic adj layer) or ALD)	US-PGPUB; USPAT	OR	ON	2004/03/19 16:33
S57	17	((((silicon adj (oxide dioxide)) "Sio.sub.2") same ("siCl.sub.4" or DCS or HCD or "si.sub.2 cl.sub.6" or "siH.sub.2 Cl.sub.2")) and (pulse with seconds)) and ((atomic adj layer) or ALD)	US-PGPUB; USPAT	OR	ON	2004/03/19 16:38
S58	5	((((silicon adj (oxide dioxide)) "Sio.sub.2") same ("siCl.sub.4" or DCS or HCD or "si.sub.2 cl.sub.6" or "siH.sub.2 Cl.sub.2")) and (pulse with (ms secs sec msec seconds))) and ((atomic adj layer) or ALD)) not (((silicon adj (oxide dioxide)) "Sio.sub.2") same ("siCl.sub.4" or DCS or HCD or "si.sub.2 cl.sub.6" or "siH.sub.2 Cl.sub.2")) and (pulse with seconds)) and ((atomic adj layer) or ALD))	US-PGPUB; USPAT	OR	ON	2004/03/19 16:38
S59	86	(((silicon adj (oxide dioxide)) "Sio.sub.2") same ("siCl.sub.4" or DCS or HCD or "si.sub.2 cl.sub.6" or "siH.sub.2 Cl.sub.2")) and ((atomic adj layer) ald)	US-PGPUB; USPAT	OR	ON	2004/03/19 16:39

S60	75	(((((silicon adj (oxide dioxide)) "Sio.sub.2") same ("siCl.sub.4" or DCS or HCD or "si.sub.2 cl.sub.6" or "siH.sub.2 Cl.sub.2")) and ((atomic adj layer) ald)) not (@ad>"20021230" or @rlad>"20021030"))	US-PGPUB; USPAT	OR	ON	2004/03/19 17:24
S61	75	(((((silicon adj (oxide dioxide)) "Sio.sub.2") same ("siCl.sub.4" or DCS or HCD or "si.sub.2 cl.sub.6" or "siH.sub.2 Cl.sub.2")) and ((atomic adj layer) ald)) not (@ad>"20021230" or @rlad>"20021030")) and (seconds msec msec ms time milliseconds millisecs)	US-PGPUB; USPAT	OR	ON	2004/03/19 17:22
S62	12	((aluminum adj oxide) or "al.sub.2 o.sub.3") same (TMA trimethylaluminum (trimethyl adj aluminum)) same plasma and (ald (atomic adj layer))	US-PGPUB; USPAT	OR	ON	2004/03/19 17:44
S63	11	((aluminum adj oxide) or "al.sub.2 o.sub.3") same (TMA trimethylaluminum (trimethyl adj aluminum)) same plasma and (ald (atomic adj layer))) not (@ad>"20021230" or @rlad>"20021030"))	US-PGPUB; USPAT	OR	ON	2004/03/19 17:45
S64	24	((aluminum adj oxide) or "al.sub.2 o.sub.3") and ((TMA trimethylaluminum (trimethyl adj aluminum)) same plasma) and (ald (atomic adj layer))	US-PGPUB; USPAT	OR	ON	2004/03/19 17:54
S65	13	((aluminum adj oxide) or "al.sub.2 o.sub.3") and ((TMA trimethylaluminum (trimethyl adj aluminum)) same plasma) and (ald (atomic adj layer))) not (((aluminum adj oxide) or "al.sub.2 o.sub.3") same (TMA trimethylaluminum (trimethyl adj aluminum)) same plasma and (ald (atomic adj layer))) not (@ad>"20021230" or @rlad>"20021030"))	US-PGPUB; USPAT	OR	ON	2005/01/21 14:54

S66	8	(((((aluminum adj oxide) or "al.sub.2 o.sub.3") and ((TMA trimethylaluminum (trimethyl adj aluminum)) same plasma) and (ald (atomic adj layer))) not (((aluminum adj oxide) or "al.sub.2 o.sub.3") same (TMA trimethylaluminum (trimethyl adj aluminum)) same plasma and (ald (atomic adj layer))) not (@ad>"20021230" or @rlad>"20021030")))) not (@ad>"20021230" or @rlad>"20021030")	US-PGPUB; USPAT	OR	ON	2004/03/19 17:49
S67	115	((aluminum adj oxide) or "al.sub.2 o.sub.3") and ((TMA trimethylaluminum (trimethyl adj aluminum)) and plasma) and (ald (atomic adj layer))	US-PGPUB; USPAT	OR	ON	2004/03/19 17:49
S68	98	((aluminum adj oxide) or "al.sub.2 o.sub.3") and ((TMA trimethylaluminum (trimethyl adj aluminum)) and plasma) and (ald (atomic adj layer)) not (@ad>"20021230" or @rlad>"20021030")	US-PGPUB; USPAT	OR	ON	2004/03/19 17:54
S69	79	(((((aluminum adj oxide) or "al.sub.2 o.sub.3") and ((TMA trimethylaluminum (trimethyl adj aluminum)) and plasma) and (ald (atomic adj layer))) not (@ad>"20021230" or @rlad>"20021030")) not (((aluminum adj oxide) or "al.sub.2 o.sub.3") and ((TMA trimethylaluminum (trimethyl adj aluminum)) same plasma) and (ald (atomic adj layer)))	US-PGPUB; USPAT	OR	ON	2004/03/19 17:49
S70	669	((aluminum adj oxide) or "al.sub.2 o.sub.3") and ((TMA trimethylaluminum (trimethyl adj aluminum)) same2 plasma) and (ald (atomic adj layer))	US-PGPUB; USPAT	OR	ON	2004/03/19 17:55
S71	590	((aluminum adj oxide) or "al.sub.2 o.sub.3") and ((TMA trimethylaluminum (trimethyl adj aluminum)) same2 plasma) and (ald (atomic adj layer)) not (@ad>"20021230" or @rlad>"20021030")	US-PGPUB; USPAT	OR	ON	2004/03/19 17:56

S72	208	((aluminum adj oxide) or "al.sub.2 o.sub.3") same ((TMA trimethylaluminum (trimethyl adj aluminum)) same2 plasma) and (ald (atomic adj layer))	US-PGPUB; USPAT	OR	ON	2004/03/19 18:21
S73	183	((aluminum adj oxide) or "al.sub.2 o.sub.3") same ((TMA trimethylaluminum (trimethyl adj aluminum)) same2 plasma) and (ald (atomic adj layer))) not (@ad>"20021230" or @rlad>"20021030")	US-PGPUB; USPAT	OR	ON	2004/03/19 18:21
S74	12	((aluminum adj oxide) or "al.sub.2 o.sub.3") same ((TMA trimethylaluminum (trimethyl adj aluminum)) same plasma) and (ald (atomic adj layer))	US-PGPUB; USPAT	OR	ON	2004/03/20 14:57
S75	114	((aluminum adj oxide) or "al.sub.2 o.sub.3") same ((TMA trimethylaluminum (trimethyl adj aluminum)) and plasma) and (ald (atomic adj layer))	US-PGPUB; USPAT	OR	ON	2004/03/19 18:21
S76	98	((aluminum adj oxide) or "al.sub.2 o.sub.3") same ((TMA trimethylaluminum (trimethyl adj aluminum)) and plasma) and (ald (atomic adj layer))) not (@ad>"20021230" or @rlad>"20021030")	US-PGPUB; USPAT	OR	ON	2004/03/20 16:17
S77	1	("6200893").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/03/19 18:25
S78	2	10/222282	US-PGPUB; USPAT	OR	ON	2004/03/20 13:37
S79	2	10/222282 and plasma	US-PGPUB; USPAT	OR	ON	2004/03/20 13:40
S80	2	09/414526	US-PGPUB; USPAT	OR	ON	2004/03/20 13:40
S81	1	09/414526 and plasma	US-PGPUB; USPAT	OR	ON	2004/03/20 13:44
S82	1	10/227475	US-PGPUB; USPAT	OR	ON	2004/03/20 13:44
S83	1	10/227475 and plasma	US-PGPUB; USPAT	OR	ON	2004/03/20 13:45
S84	1	09/820168	US-PGPUB; USPAT	OR	ON	2004/03/20 13:45
S85	1	09/820168 and plasma	US-PGPUB; USPAT	OR	ON	2004/03/20 14:57

S86	2606	plasma with (room adj temperature)	US-PGPUB; USPAT	OR	ON	2004/03/20 14:57
S87	28	((plasma with (room adj temperature)) and ((aluminum adj oxide) or "al.sub.2 o.sub.3") and (ald (atomic adj layer)))	US-PGPUB; USPAT	OR	ON	2004/03/20 16:17
S88	153	ALd and (plasma with time)	US-PGPUB; USPAT	OR	ON	2004/03/20 16:27
S89	1	((10/227475 and plasma) and ((aluminum adj oxide) or "al.sub.2 o.sub.3"))	US-PGPUB; USPAT	OR	ON	2004/03/20 16:18
S90	32	((ALd and (plasma with time))) and ((aluminum adj oxide) or "al.sub.2 o.sub.3"))	US-PGPUB; USPAT	OR	ON	2004/03/20 16:18
S91	26	ALd and (plasma with advantage)	US-PGPUB; USPAT	OR	ON	2004/03/20 18:40
S92	0	(09/820168).CCLS.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/03/20 18:40
S93	1	09/820168	US-PGPUB; USPAT	OR	OFF	2005/01/21 14:51
S94	1	09/820168 and (controlled uniform\$)	US-PGPUB; USPAT	OR	OFF	2004/03/20 18:51
S95	1	("6689220").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2004/03/20 18:51
S96	1	((("6689220").PN.) and plasma	US-PGPUB; USPAT	OR	OFF	2004/03/20 20:29
S97	9936	Bipolar and epitaxial	US-PGPUB; USPAT	OR	OFF	2004/03/20 20:31
S98	47	Bipolar and (in adj situ adj dop\$)	US-PGPUB; USPAT	OR	OFF	2004/03/20 20:32